

What is claimed is:

1. A magnetic thin film head comprising:

a write head element; and

5 a read head element;

wherein a ferromagnetic film having a soft magnetic characteristic and a magnetic shield function is formed of NiFe permalloy material by electroplating in the vicinity of a sensor film arranged as said read

10 head element,

wherein Ni in composition of a formed layer is 80.8wt% to 82.0wt%.

2. A magnetic thin film head according to

15 claim 1, in which said Ni is composed of an initially formed layer having a thickness of 1.0  $\mu$  m is 80.8 to 82.0 wt%, and of an upper layer on said initially formed layer 1.0  $\mu$  m thick is 81.0 to 81.2 wt%.

20 3 A magnetic thin film head comprising:

a write head element; and

a read head element;

wherein a ferromagnetic film having a soft magnetic characteristic and a magnetic shield function is formed of NiFe permalloy material by electroplating in the vicinity of a sensor film arranged as said read

25 head element,

wherein a magnetostriction constant  $\lambda$

representing a magnetic characteristic of said ferromagnetic film is  $-2.0$  to  $-7.0 \times 10^{-7}$  in an initially formed layer having a thickness of  $1.0 \mu m$ , and

5 wherein said magnetostriction constant  $\lambda$  is  $-3.0$  to  $-4.0 \times 10^{-7}$  in an upper layer on said initially formed layer  $1.0 \mu m$  thick.

4 A magnetic thin film head comprising:

10 a write head element; and  
a read head element;

wherein a ferromagnetic film having a soft magnetic characteristic and a magnetic shield function is formed of NiFe permalloy material by electroplating  
15 in the vicinity of a sensor film arranged as said read head element,

wherein a film thickness exceeding  $1.0 \mu m$  in said ferromagnetic film formed of NiFe permalloy material has an Ni content accuracy of  $\pm 0.1$  wt%, and

20 wherein a film thickness of  $1.0 \mu m$  or less in said ferromagnetic film formed of NiFe permalloy material has an Ni content accuracy of  $\pm 0.3$  wt%.

5. A method of fabricating a magnetic thin film comprising the step of:

(a) forming a write head element;

(b) forming a read head element;

wherein a ferromagnetic film having a soft

magnetic characteristic and a magnetic shield function is formed of NiFe permalloy material by electroplating in the vicinity of a sensor film arranged as said read head element,

5 wherein Ni in composition of an initially formed layer having a thickness of  $1.0 \mu m$  is 80.8 to 82.0 wt%, and

10 wherein Ni in composition of an upper layer on said initially formed layer  $1.0 \mu m$  thick is 81.0 to 81.2 wt%,

→ (c) timewise regulating a current density of permalloy electroplating under control of a personal computer;

15 wherein a plurality of time periods and a plurality of current values are preset for film formation.

6. A method of fabricating a magnetic thin film comprising the step of:

20 (a) forming a write head element; and

(b) forming a read head element;

wherein a ferromagnetic film having a soft magnetic characteristic and a magnetic shield function is formed of NiFe permalloy material by electroplating in the vicinity of a sensor film arranged as said read head element,

25 wherein a magnetostriction constant  $\lambda$  representing a magnetic characteristic of said

ferromagnetic film is  $-2.0$  to  $-7.0 \times 10^{-7}$  in an initially formed layer having a thickness of  $1.0 \mu m$ , and

5 wherein said magnetostriction constant  $\lambda$  is  $-3.0$  to  $-4.0 \times 10^{-7}$  in an upper layer on said initially formed layer  $1.0 \mu m$  thick,

→ (c) timewise regulating a current density of permalloy electroplating under control of a personal computer;

10 wherein a plurality of time periods and a plurality of current values are preset for film formation.

7. A method of fabricating a magnetic thin film comprising the step of:

- (a) forming a write head element; and
- (b) forming a read head element;

15 wherein a ferromagnetic film having a soft magnetic characteristic and a magnetic shield function is formed of NiFe permalloy material by electroplating in the vicinity of a sensor film arranged as said read head element,

20 wherein a film thickness exceeding  $1.0 \mu m$  in said ferromagnetic film formed of NiFe permalloy material has an Ni content accuracy of  $\pm 0.1$  wt%, and

25 wherein a film thickness of  $1.0 \mu m$  or less in said ferromagnetic film formed of NiFe permalloy material has an Ni content accuracy of  $\pm 0.3$  wt%,

(c) timewise regulating a current density of permalloy electroplating under control of a personal computer;

5 wherein a plurality of time periods and a plurality of current values are preset for film formation.

8 A magnetic disk apparatus having a magnetic thin film head comprising:

10 a write head element; and  
a read head element;

wherein a ferromagnetic film having a soft magnetic characteristic and a magnetic shield function is formed of NiFe permalloy material by electroplating 15 in the vicinity of a sensor film arranged as said read head element,

wherein Ni in composition of an initially formed layer having a thickness of  $1.0 \mu m$  is 80.8 to 82.0 wt%, and

20 wherein Ni in composition of an upper layer on said initially formed layer  $1.0 \mu m$  thick is 81.0 to 81.2 wt%.

9 A magnetic disk apparatus having a magnetic thin film head comprising:

a write head element; and  
a read head element;

wherein a ferromagnetic film having a soft

magnetic characteristic and a magnetic shield function is formed of NiFe permalloy material by electroplating in the vicinity of a sensor film arranged as said read head element,

5       wherein a magnetostriiction constant  $\lambda$  representing a magnetic characteristic of said ferromagnetic film is -2.0 to  $-7.0 \times 10^{-7}$  in an initially formed layer having a thickness of  $1.0 \mu m$ , and

10      wherein said magnetostriiction constant  $\lambda$  is -3.0 to  $-4.0 \times 10^{-7}$  in an upper layer on said initially formed layer  $1.0 \mu m$  thick.

15      10     A magnetic disk apparatus having a magnetic thin film head comprising:

A magnetic thin film head comprising:

a write head element; and

a read head element;

20      wherein a ferromagnetic film having a soft magnetic characteristic and a magnetic shield function is formed of NiFe permalloy material by electroplating in the vicinity of a sensor film arranged as said read head element,

25      wherein a film thickness exceeding  $1.0 \mu m$  in said ferromagnetic film formed of NiFe permalloy material has an Ni content accuracy of  $\pm 0.1$  wt%, and wherein a film thickness of  $1.0 \mu m$  or less in said ferromagnetic film formed of NiFe permalloy

material has an Ni content accuracy of  $\pm 0.3$  wt%.